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> JP2000345041A2: COMPOSITION FOR FORMING FILM, PRODUCTIC প্ল Title:

COMPOSITION FOR FORMING FILM, AND MATERIAL FOR FORMING

INSULATION FILM

Composition for film formation for production of semiconductors, PDerwent Title:

comprises a product of hydrolysis and condensation obtained by

hydrolyzing and condensing organosilicon compound(s) [Derwent Record]

JP Japan ਊ Country:

A2 Document Laid open to Public inspection i 郞Kind:

NISHIKAWA MICHINORI;

TSUNODA MAYUMI; **INOUE YASUTAKE**; YAMADA KINJI;

JSR CORP

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2000-12-12 / 1999-06-04 Published / Filed:

> JP1999000158674

Number:

C08L 83/04; C08K 5/06; H01L 21/312; H01L 21/316; 郞IPC Code:

1999-06-04 JP1999000158674 Priority Number:

> PROBLEM TO BE SOLVED: To obtain a composition having

improved storage stability and giving a film improved in uniformity,

permittivity, and leak current characteristics by selecting a composition containing a hydrolyzate of a silane compound or a condensate of the hydrolyzate and having a specified propylene

glycol content.

SOLUTION: This composition contains at least either of a hydrolyzate and/or a condensate selected from a compound of formula I and a compound of formula II and a solvent of formula III of a purity of 99% (as measured by gas chromatography) and has a propylene glycol content of 10,000 ppm or below. In the formula, R1 is H. F. or a monovalent organic group; R2 to R6 are each a monovalent organic group; a, b, and c are each 0-2; R7 is O or -(CH2)n-; in formula II, n is 1-6; d is 0 or 1; R8 and R9 are each a monovalent organic group selected from H, a 1-4C alkyl, and CH3CO-; and e is 1-2. The composition desirably has an iron content and a sodium content each of which is 15 ppb or below and

may contain a β -diketone, a compound having a polyalkylene oxide structure, or the like.

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图	US6376634	2002-04-23	2000-06-02	Composition for film formation and mainsulating film formation
Ø	JP2001164113A2	2001-06-19	1999-12-13	COMPOSITION FOR FILM FORMATION MATERIAL FOR FORMING INSULAT
Ø	JP2000345041A2	2000-12-12	1999-06-04	COMPOSITION FOR FORMING FILM PRODUCTION OF COMPOSITION FORMING FILM, AND MATERIAL FOFORMING INSULATION FILM
×	EP1058274B1	2005-07-27	2000-05-31	Composition for film formation and mainsulating film formation
迭	EP1058274A1	2000-12-06	2000-05-31	Composition for film formation and mainsulating film formation
	DE60021476C0	2005-09-01		Beschichtungszusammensetzung für c Filmherstellung und Material für isolier Schichten
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